



PATENT
Docket No.: ACT-311

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2815

Examiner: Jose R. Diaz

Serial No.: 09/737,642

Filed: December 14, 2000

In re Application of: Daniel C. Wang

For: METAL-TO-METAL ANTIFUSE STRUCTURE AND FABRICATION
METHOD

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 6/24/03.

Signed Stephanie Davis
Stephanie Davis

11/C
7/11/03
Jun.

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following is being submitted in response to the Office Action dated March 14, 2003. Please amend the application as follows:

RECEIVED
JUN - 1 2003
TECHNOLOGY CENTER 2800